Customer No.: 31561 Application No.: 10/708,488 Docket No.: 12476-US-PA

AMENDMENTS

Please amend the application as indicated hereafter.

To the Claims:

1. (original) A method of forming a bond midrostructure, comprising:

sequentially forming a tin layer and a gold ayer on one of two members, a % weight ratio of tin to gold being 20:80 having a variation range of about ±3~4%; and

treating the tin layer and the gold layer with a first temperature or a second temperature to form bond microstructures having different characteristics, wherein when the tin layer and the gold layer are treated with the first temperature, the bond microstructure will have a layered structure and when the tin layer and the gold layer are treated with the second temperature, the bond microstructure will have an eutectic structure.

- 2. (original) The method of claim 1, wherein the first temperature is no more than 280°C.
- 3. (original) The method of claim 1, wherein the bond microstructure having the layered structure comprises an AuSn layer and an Au₃Sn layer.
- 4. (original) The method of claim 1, wherein the second temperature is higher than 280°C.
- 5. (original) The method of claim 1, wherein the bond microstructure having the eutectic structure comprises AuSn and Au₅Sn.
 - 6. (cancelled)

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- 7. (original) The method of claim 1, wherein the the gold layer is formed over the tin layer.
- 8. (original) The method of claim 1, wherein the tin layer is formed over the gold layer.
- 9. (original) The method of claim 1, wherein the tin layer is formed by performing an electroplating process, an evaporation process, an electroless plating or a sputtering process.
- 10. (original) The method of claim 1, further comprising forming an adhesion layer, a barrier layer and a wetting layer on one or both of the two members before forming the tin layer and the gold layer on one of the two members.
 - 11-13. (cancelled)
- 14. (original) The method of claim 1, wherein the two members comprise a flip chip and a substrate.
- 15. (original) The method of claim 1, wherein the two members comprise a photo-electronic device and a substrate.
- 16. (original) A method of forming a bond microstructure, comprising:
 sequentially forming a tin layer and a gold layer on two members respectively, the
 weight ratio of tin to gold being 20:80 having a variation range about ±3~4%; and

treating the tin layer and the gold layer with a first temperature or a second temperature to form bond microstructures having different characteristics, wherein when the tin layer and the gold layer are treated with the first temperature, the bond

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microstructure will have a layered structure and when the tin layer and the gold layer are treated with the second temperature, the bond microstructure will have an eutectic structure.

- 17. (original) The method of claim 16, wherein the first temperature is no more than 280°C.
- 18. (original) The method of claim 16, wherein the bond microstructure having the layered structure comprises an AuSn layer and an Au₅Sn layer.

19-20. (cancelled)

- 21. (original) The method of claim 16, wherein the step of treating the tin layer and the gold layer with the first temperature of the second temperature comprises heating under pressure or a reflowing method.
- 22. (original) The method of claim 16, wherein the tin layer is formed by performing an electroplating process, an evaporation process, an electroless plating process or a sputtering process.
- 23. (original) The method of claim 16, further comprising forming an adhesion layer, a barrier layer and a wetting layer on one or both of the two members before forming the tin layer and the gold layer on the two members.

24-26 (cancelled)

- 27. (original) The method of claim 16, wherein the two members comprise a flip chip and a substrate.
- 28. (original) The method of claim 16, wherein the two members comprise a photo-electronic device and a substrate.

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